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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)			Application Number	10/760,023	
			Filing Date	1/16/04	
			First Named Inventor	Honda	
			Group Art Unit	2821	
			Examiner Name	Shih-Hwo Chen	
Sheet	1	of	1	Attorney Docket Number	MN1-019US

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
le		Y.T. Lo & S.W. Lee, Antenna Handbook, Vol. II, Van Nostrand Reinhold, New York, 1993, pp. 15-51 to 15-61.	
le		Walter Rotman, "Wide Angle Scanning with Microwave Double-Layer Pillboxes", IRE Transactions on Antennas and Propagation, vol. 6, pp. 96-105; January, 1958.	
le		Y.T. Lo & S.W. Lee, Antenna Handbook, Vol. II, Van Nostrand Reinhold, New York, 1993, pp. 19-19 to 19-23.	

Examiner Signatur	Shih-Hwo Chen	Date Considered	7/18/05
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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